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**\*BIBDATASHEET\*****CONFIRMATION NO. 5527**

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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\*** *yes A1*  
 This application is a DIV of 09/880,932 06/15/2001 ABN

**\*\* FOREIGN APPLICATIONS \*\*\*\*\*** *yes A1*  
 JAPAN 2000-193734 06/28/2000  
 JAPAN 2001-067042 03/09/2001  
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**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**  
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR  COUNTRY JAPAN	SHEETS  DRAWING 9	TOTAL  CLAIMS 15	INDEPENDENT  CLAIMS 9
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>A1</i>				

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**TITLE**  
 Hexagonal boron nitride film with low dielectric constant, layer dielectric film and method of production thereof, and plasma CVD apparatus